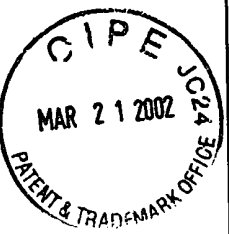


1765



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#3  
4-9-02

Applicant(s): Omstead, Thomas R.; Levy, Karl B.;  
Title: ATOMIC LAYER DEPOSITION SYSTEMS AND METHODS  
Serial No.: 10/028,610 Filed: December 19, 2001  
Examiner: Unknown Group Art Unit: 1765  
Docket No.: M-11953 US

San Jose, California  
March 21, 2002

**NOTICE OF CHANGE OF ADDRESS**

COMMISSIONER FOR PATENTS  
Washington, D. C. 20231

Sir:

Please direct all correspondence in the above-identified application and with respect to  
any patent that issues on this application to the undersigned at this address:

Greg J. Michelson  
c/o SKJERVEN MORRILL MacPHERSON LLP  
25 Metro Drive, Suite 700  
San Jose, California 95110  
Telephone: 949-718-5200

EXPRESS MAIL LABEL NO.  
  
EL849435968US  
  
**RECEIVED**  
APR 1 - 2002

Respectfully submitted,

*Greg J. Michelson*

Greg J. Michelson  
Attorney for Applicant(s)  
Reg. No. 44,940

**TC 1700**